DEC 0'2 1005 DE

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

n re the Application of: Kenichi ATANABE et al.

Group Art Unit: 2826

office petition

Serial No.: 10/622,614

Examiner: Alexander O. Williams

Filed: July 21, 2003

Confirmation No.: 2630

For:

SEMICONDUCTOR DEVICE FOR PREVENTING DEFECTIVE FILLING OR INTERCONNECTION AND CRACKING OF

INSULATING FILM

Attorney Docket Number:

030877

Customer Number:

38834

PETITION FOR WITHDRAWAL FROM ISSUE UNDER 37 C.F.R. §1.313(c)(2)

OFFICE OF PETITIONS Mail Stop 313(c) Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450 December 2, 2005

Sir:

Applicants respectfully request that the present application be withdrawn from issue for consideration of a Request for Continued Examination and the attached Information Disclosure Statement.

A Request for Continued Examination and an Information Disclosure Statement are submitted concurrently herewith.

If this paper is not considered to be timely filed, the Applicants hereby petition for an appropriate extension of the response period. Please charge the fee for such extension and any other fees which may be required to our Deposit Account No. 50-2866.

Respectfully submitted,

WESTERMAN, HATTORI, DANIELS & ADRIAN, LLP

12/05/2005 SZEWDIE1 00000057 10622614

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Attachments: Request for Continued Examination (RCE)

Information Disclosure Statement (IDS)